AUG 0 6 2001	Under the Paperwork Reduction Activated OMB control number. TRANSMIT FORM (to be used for all correspondence activated Number of Pages in This Subm	TAL fter initial filing)	Patent and Trademark Of	Kie Y. Ahn et al. 2812 Unknown er MI22-1533
	Fee Transmittal Form Fee Attached Amendment / Response After Final Affidavits/declaration(s) Extension of Time Request Express Abandonment Request Information Disclosure Statement Certified Copy of Priority Document(s) Response to Missing Parts/ Incomplete Application Response to Missing Parts under 37 CFR 1.52 or 1.53	Assignm (for an Assignm (for a	nent Papers Application) g(s) g-related Papers Routing Slip (PTO/SB/69) companying Petition to Convert to a nal Application of Attorney, Revocation of Correspondence	After Allowance Communication to Group Appeal Communication to Board of Appeals and Interferences Appeal Communication to Group (Appeal Notice, Brief, Reply Brief) Proprietary Information Status Letter X Additional Enclosure(s) (please identify below): PTO Return Postcard
or Inc Sig Da	SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT Firm or Individual name David G. Latwesen, Ph.D.; Reg. No. 38,533; Wells, St. John et al. Signature Date CERTIFICATE OF MAILING I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231 on this date: 08/02/2001 Typed or printed name Muriel Dunnigan Signature Muriel Dunnigan Signature Date Muriel Dunnigan			

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#2/IOS DKing 8/22/0

Inventors: Kie Y. Ahn et al.

Title:

Methods of Forming Silicon-Doped Aluminum Oxide, and

Methods of Forming Transistors and Memory Devices

Assignee:

Micron Technology, Inc.

Serial No.

09/754,926

Filed:

January 4, 2001

INFORMATION DISCLOSURE STATEMENT

PURSUANT TO 37 C.F.R. §§ 1.56, 1.97 AND 1.98

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, the Examiner's attention is directed to the references listed on the attached Form PTO-1449 and copies of which are attached. No admission is made regarding whether all the submitted references are prior art.

Citation of these references are respectfully requested.

Respectfully submitted,

Date:

Attornev:

David G. Latwesen, Ph.D.

Reg. No. 38,533

Wells, St. John, Roberts, Gregory & Matkin, P.S.